



PATENT  
Docket No.: MAN-013

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2811

Examiner: Hu, Shouxiang

Serial No.: 10/723,285

Filed: November 25, 2003

In re Application of: Werner et al.

For: SEMICONDUCTOR STRUCTURE FOR USE IN THE NEAR INFRARED REGION AND A METHOD OF MANUFACTURING THIS SEMICONDUCTOR STRUCTURE

## Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail, in an envelope addressed Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 12/5/05.

Signed Krista Thompson  
Krista Thompson

## REQUEST FOR EXTENSION OF TIME

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicants request an extension of time of two months to respond to the Office Action dated July 5, 2005. Enclosed is the requisite fee of \$225.00 as calculated pursuant to 37 C.F.R. §1.17(a-c) below:

One month extension  
Two month extension  
Three month extension

Small Entity	Std. Fee
<input type="checkbox"/> \$ 60.00	<input type="checkbox"/> \$120.00
<input checked="" type="checkbox"/> \$225.00	<input type="checkbox"/> \$450.00
<input type="checkbox"/> \$510.00	<input type="checkbox"/> \$1,020.00

The Assistant Commissioner is hereby authorized to charge any additional fees or credit any overpayment to Deposit Account No.: 50-0612.

Respectfully submitted,  
SIERRA PATENT GROUP, LTD.



William P. Wilbar  
Reg. No. 43,265

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225.00 OP

Dated: December 5, 2005

Sierra Patent Group, Ltd.  
P.O. Box 6149  
Stateline, NV 89449  
(775) 586-9500  
(775) 586-9550